IN THE CLAIMS:

The status of the claims is as follows:

1-33. (Canceled)

34. (Currently Amended) An encoded micron-sized semiconductor or insulator particle having an integral and ordered physical multi-layer porosity structure with multiple porosity interfaces between consecutive multiple porosity layers, the multiple porosity layers having multiple optical thicknesses, wherein the physical multi-layer porosity structure is configured to produce an optical signature in the form of an interference pattern in the reflectivity spectrum that uniquely corresponds to a single particular etching [[a]] code from a library of codes that was used to create the particle via a computer waveform controlled etch.

- 35. (Canceled).
- 36. (Canceled)
- 37. (Previously Presented) The particle of claim 34, further comprising a receptor within the pores of the physical multi-laver porosity structure.
- 38. (Original) The particle of claim 37, wherein said receptor is a receptor for a biological analyte.
- 39. (Original) The particle of claim 37, wherein said receptor is a receptor for a chemical analyte.
 - 40. (Original) The particle of claim 37, wherein said receptor is a receptor

for a gaseous analyte.

- 41. (Previously Presented) The particle of claim 37, further comprising a fluorescence tag within the pores of the particle for assaying the particle
- (Currently Amended) The particle of claim 34, wherein the thin film comprises the particle comprises porous silicon.
 - 43. (Canceled).
 - 44. (Canceled).
- 45. (Currently Amended) A library of optically encoded particles, comprising a plurality of particles—of—claim—35, wherein—each individual particle has a unique integral and ordered physical multi-layer porosity structure with multiple porosity interfaces between consecutive multiple porosity layers, the multiple porosity layers having multiple optical thicknesses, wherein the physical multi-layer porosity structure is configured to produce an optical signature in the form of an interference pattern in the reflectivity spectrum that uniquely corresponds to a single particular etching a code from a library of codes that was used to create the particle via a computer waveform controlled etch.
- 46. (New) The library of claim 45, wherein the multiple porosity interfaces comprise generally planar interfaces.
- 47. (New) The particle of claim 34, wherein the multiple porosity interfaces comprise generally planar interfaces.